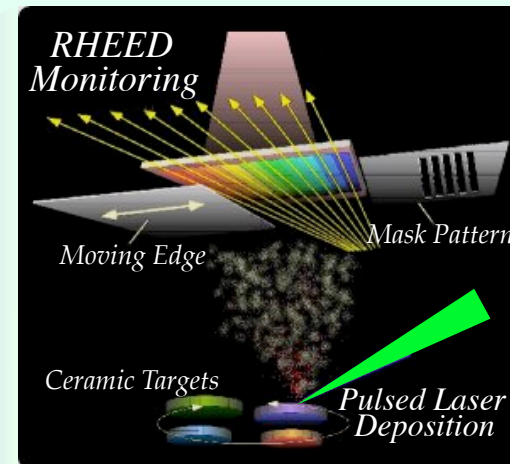
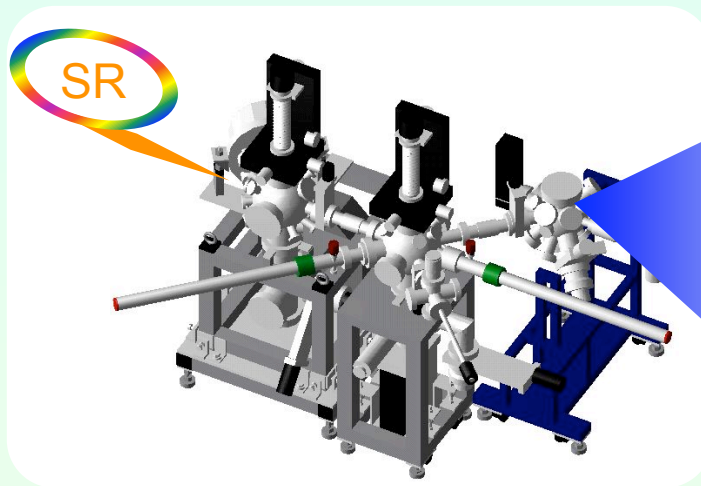


次元性制御強相関酸化物薄膜の 軟X線光電子分光

組頭 広志

KEK-PF (物構研&構造物性研究センター)

JSTさきがけ



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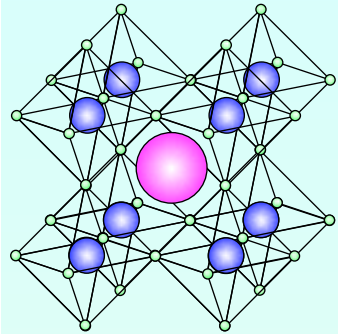
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S. Okamoto

Oak Ridge National Laboratory, Oak Ridge Tennessee 37831-6071, USA

INTRODUCTION

Transition Metal Oxides



High-Tc
CMR
M-I Transition

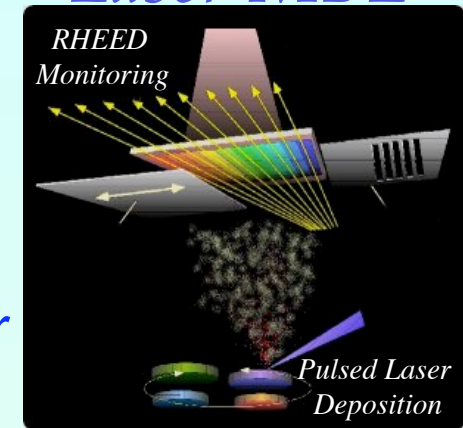
Controlling unusual
physical properties



Charge

Charge Transfer

Laser MBE



Heterostructure

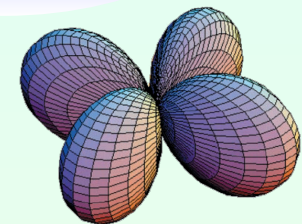
Spin

Spin Exchange

Orbital

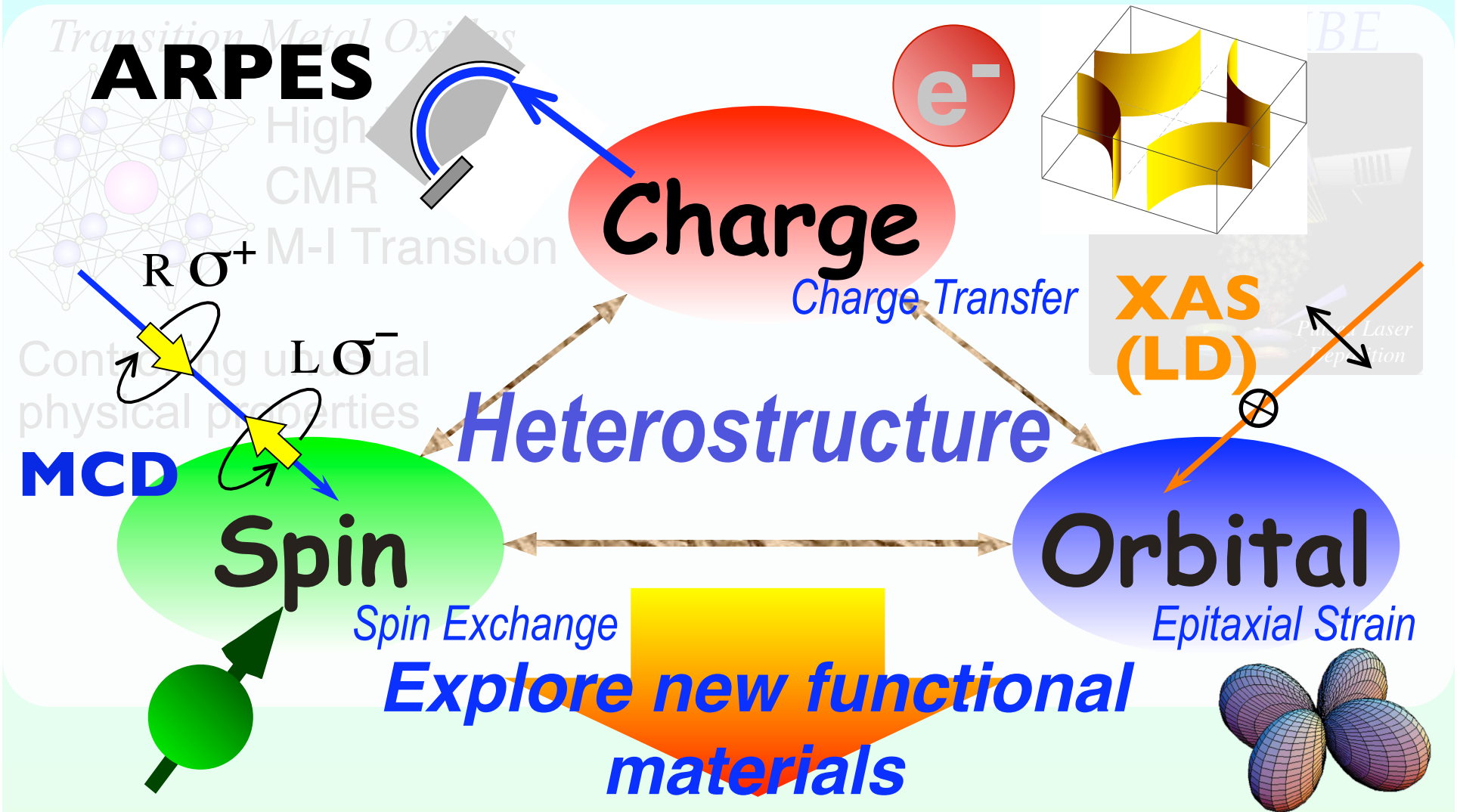
Epitaxial Strain

**Explore new functional
materials**



"in-situ Photoemission"

Oxide Artificial Structures

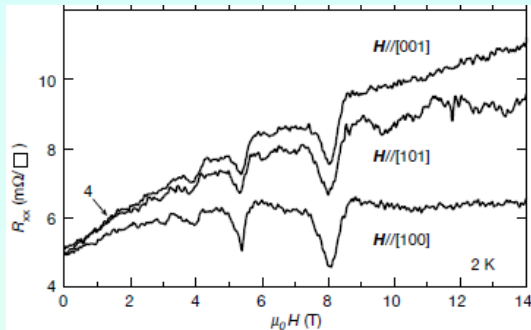


"in-situ Photoemission"

Appearance of metallic conductivity at the interface between the band insulators LaAlO_3 and SrTiO_3

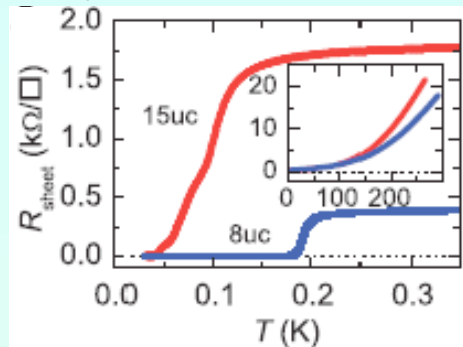
High-mobility electron gas

(A. Ohtomo *et al*, Nature 2004)



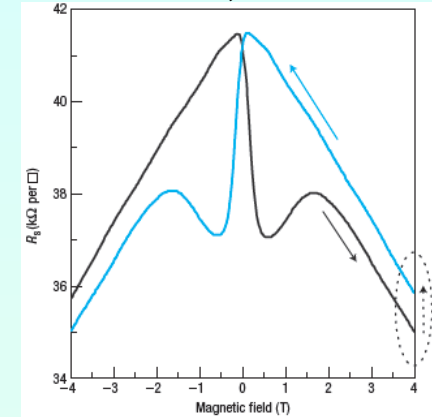
Superconductivity

(N. Reyren *et al.*, Science 2007)



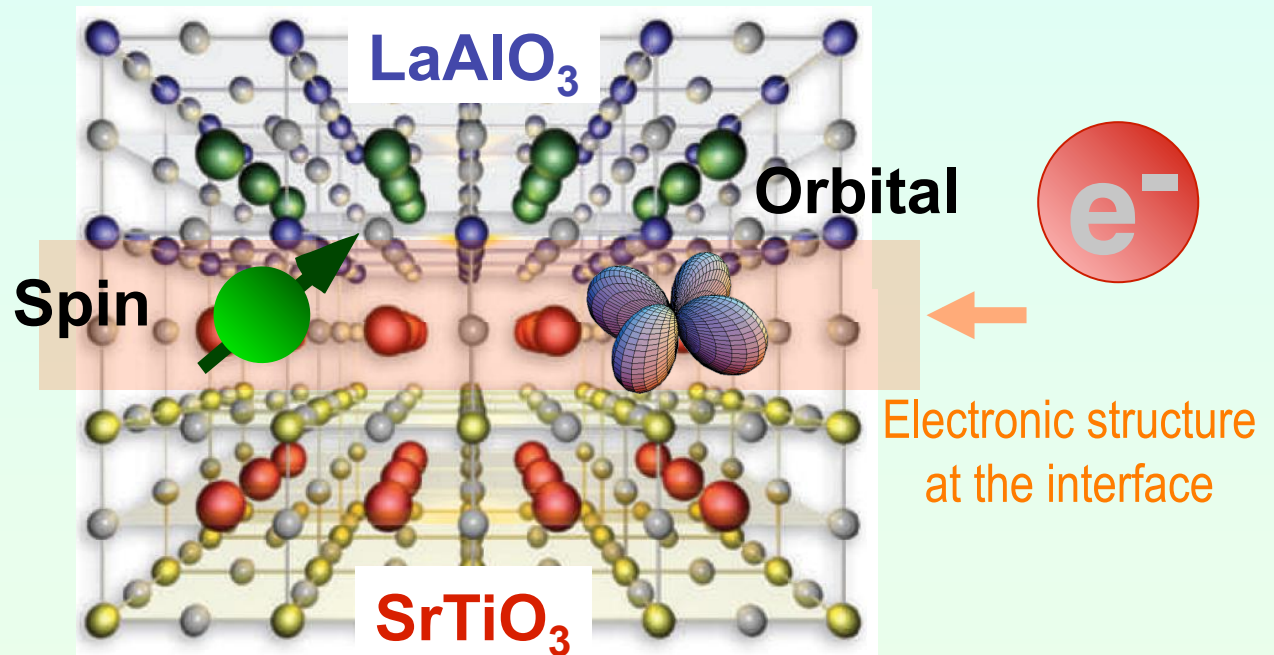
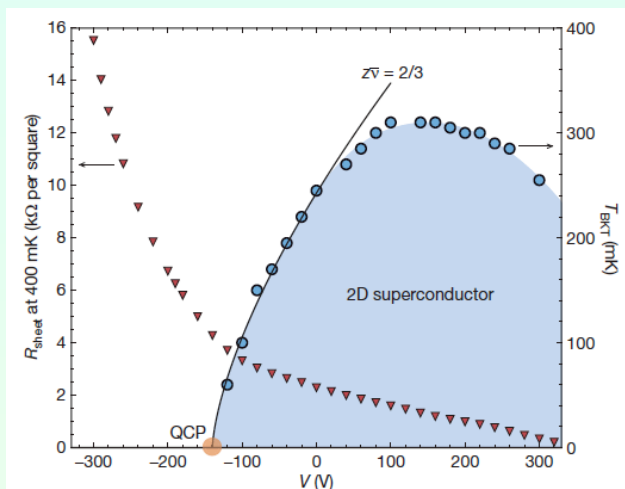
Ferromagnetism?

(A. Brinkman *et al*, Nat. Mater. 2007)

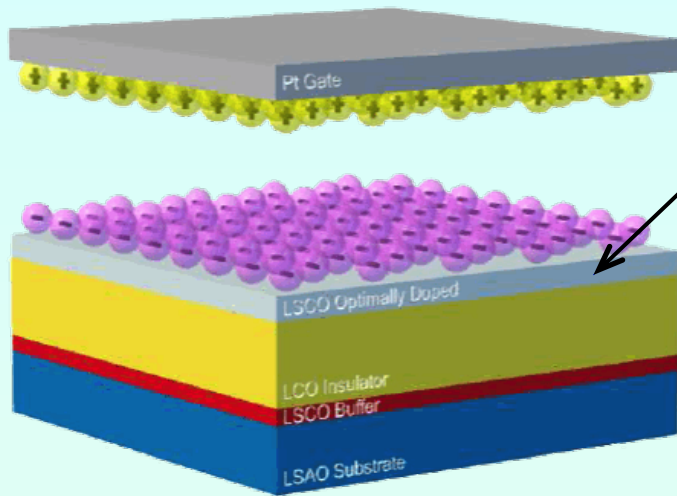


Electric field control of the superconductivity

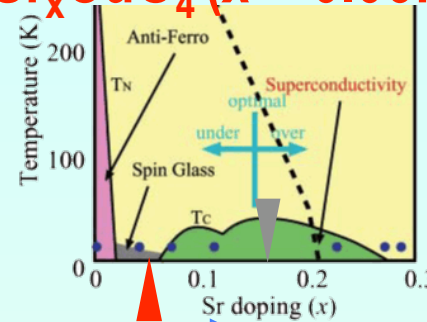
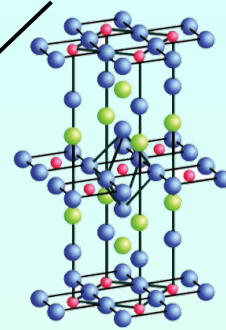
(A.D. Caviglia *et al*, Nature 2008)



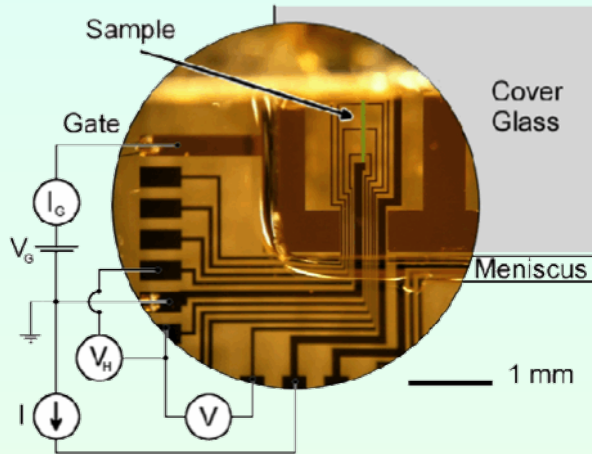
Superconductor–Insulator Transition in $\text{La}_{2-x}\text{Sr}_x\text{CuO}_4$ Driven by Electric Field



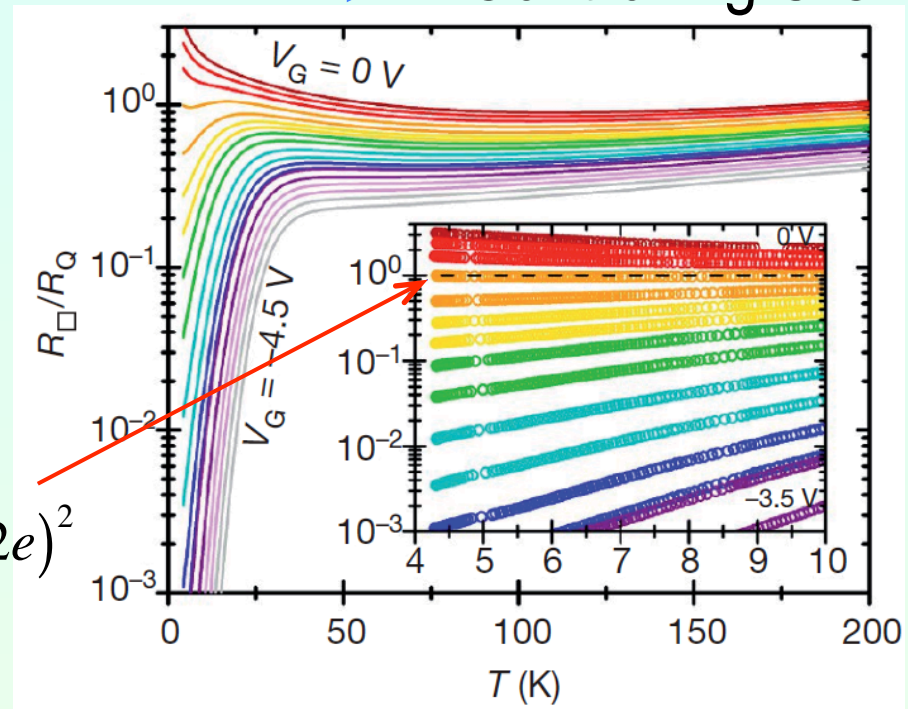
1 u.c. $\text{La}_{2-x}\text{Sr}_x\text{CuO}_4$ ($x = 0.06$: Under doped)



Controlling S.C.



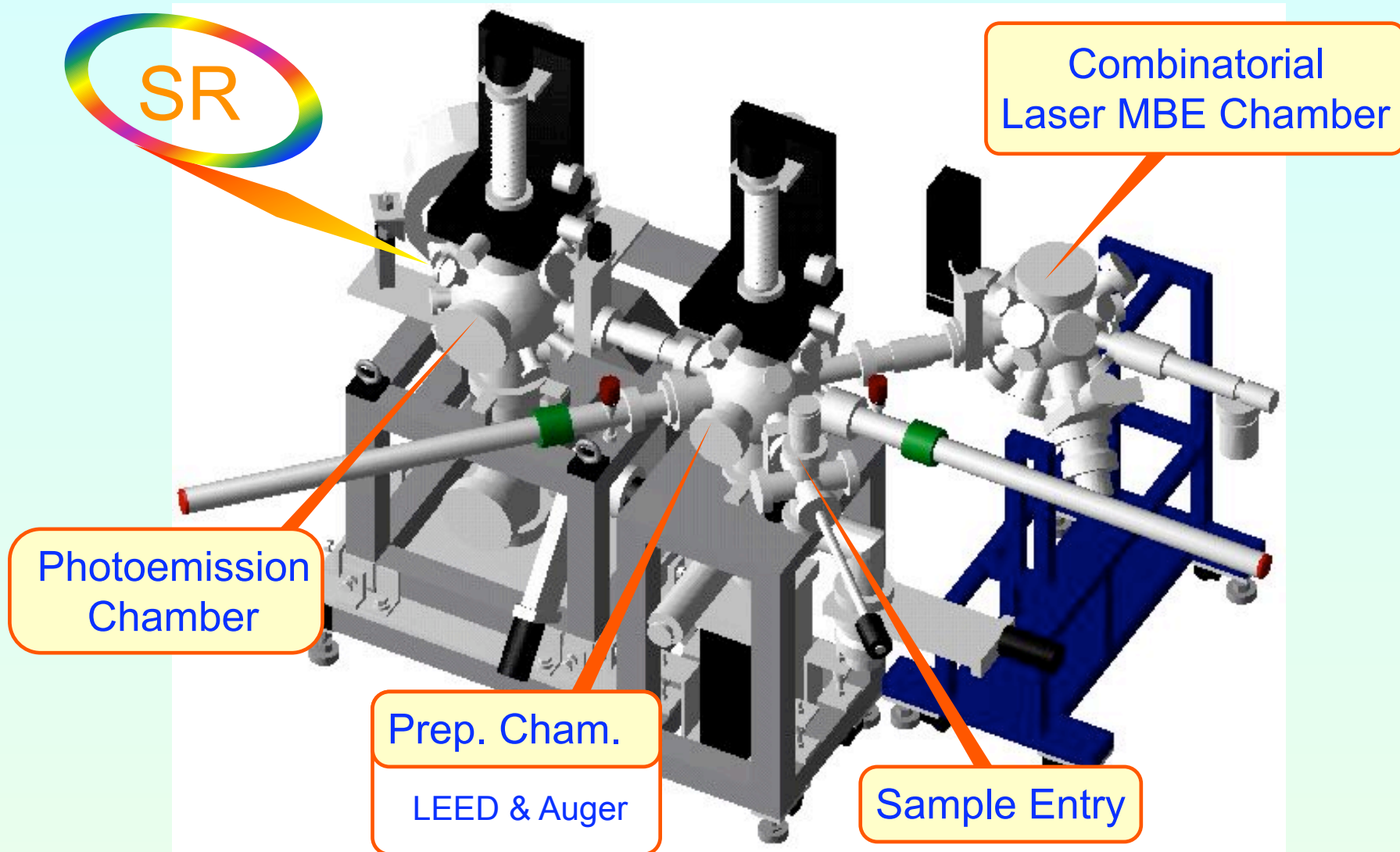
Electrolyte Double-Layer Transistor (Field Effect Transistor)



A.T. Bollinger et al., Nature 472, 458 (2011).



In-situ PES + Laser MBE system



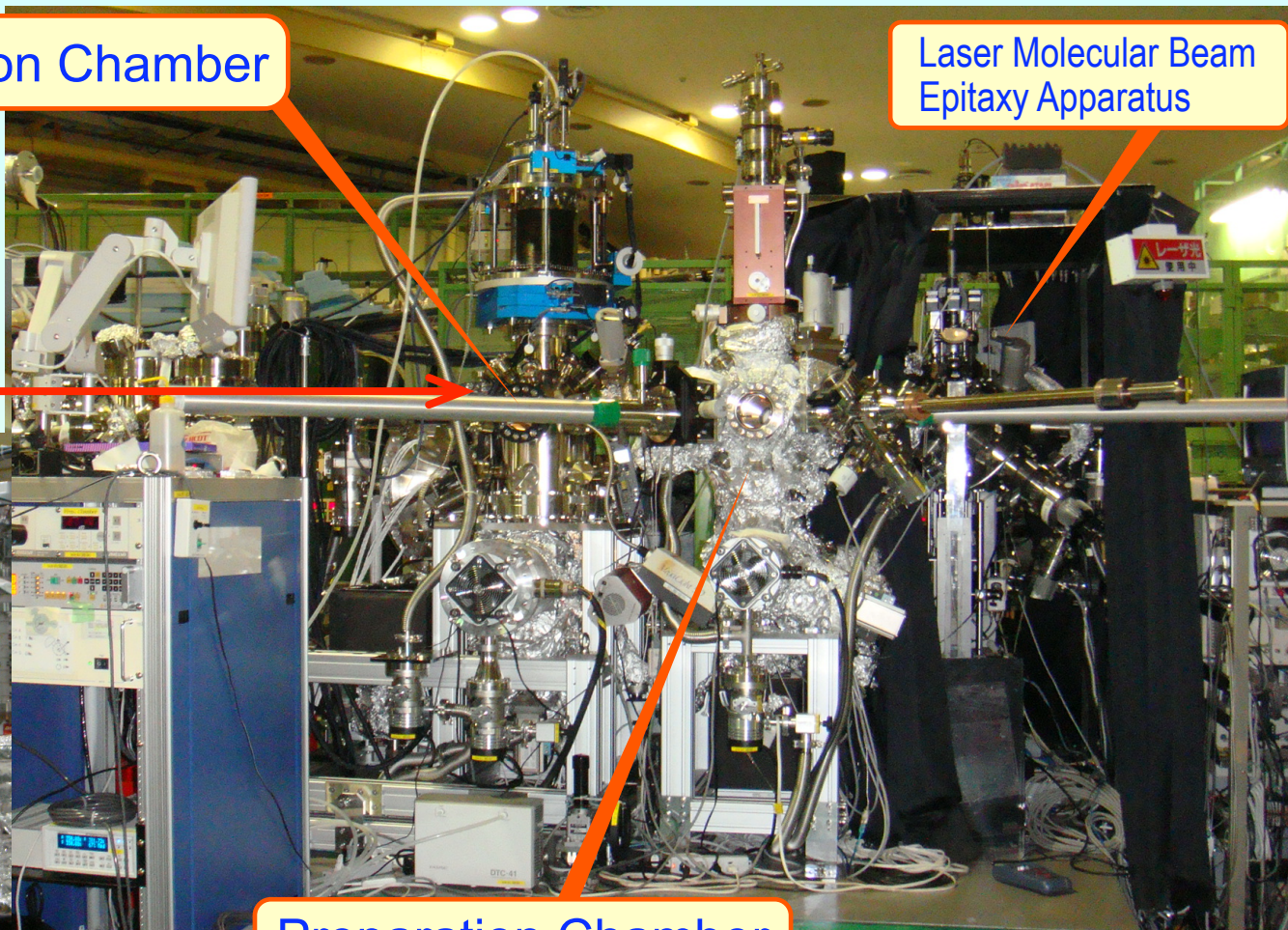
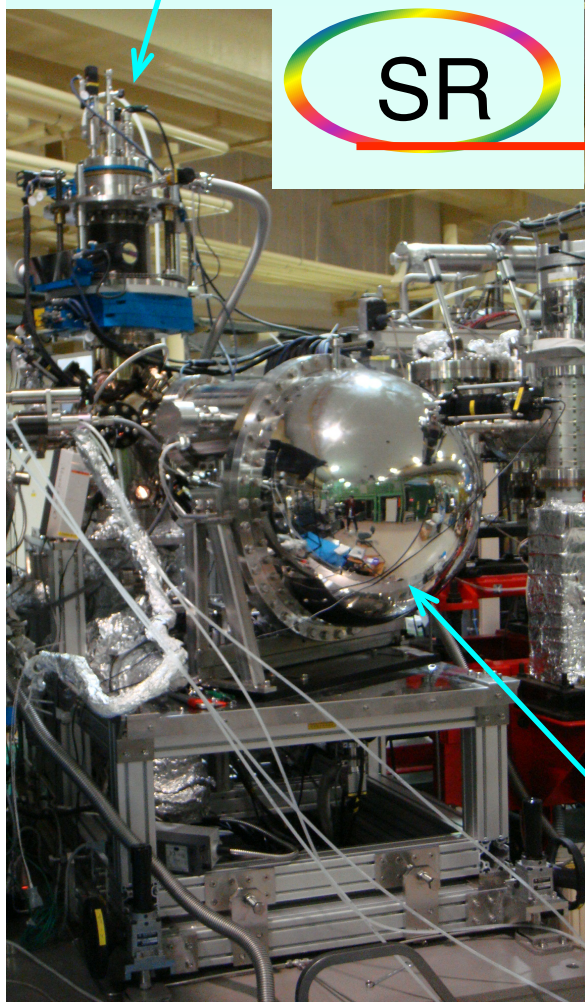


New *in-situ* PES + Laser MBE system

Photoemission Chamber

Laser Molecular Beam Epitaxy Apparatus

Manipulator
(two-axial rotating stage)

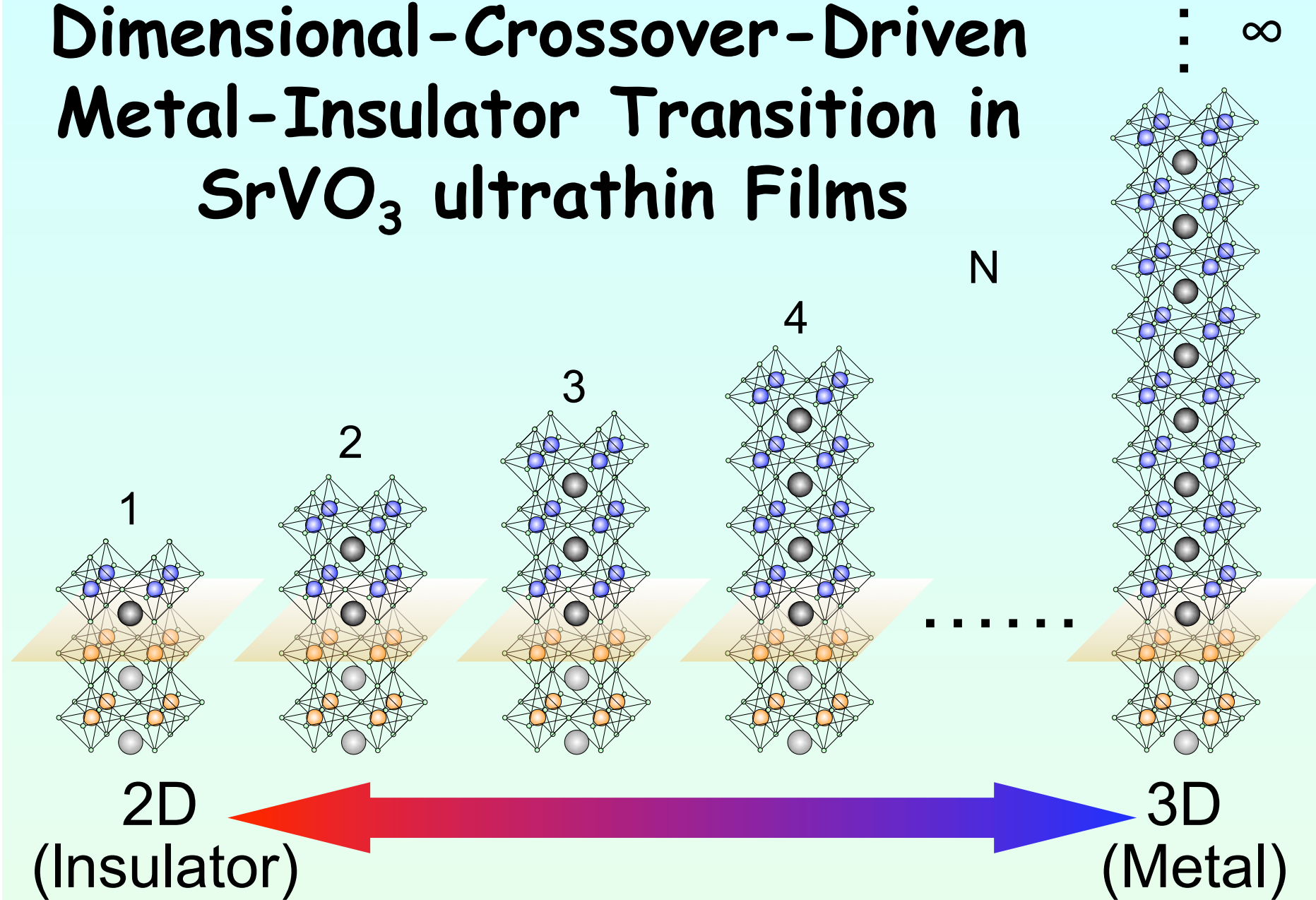


Preparation Chamber

@KEK-PF BL-2C

High resolution photoemission analyzer
VG-Scineta SES2002

Dimensional-Crossover-Driven Metal-Insulator Transition in SrVO_3 ultrathin Films



Metallic Quantum Well

K. Yoshimatsu, H.K., *et al.*, *Phys. Rev. Lett.* **104**, 147601 ('10).

K. Yoshimatsu, H.K., *et al.*, *Science* **333**, 315 ('11).

Metal Insulator Transition

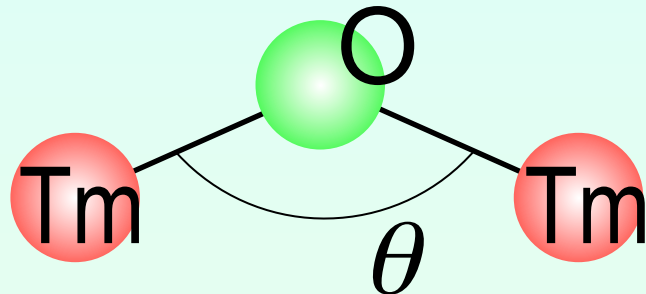
Mott-Hubbard theory

$U \gg W$ Insulator

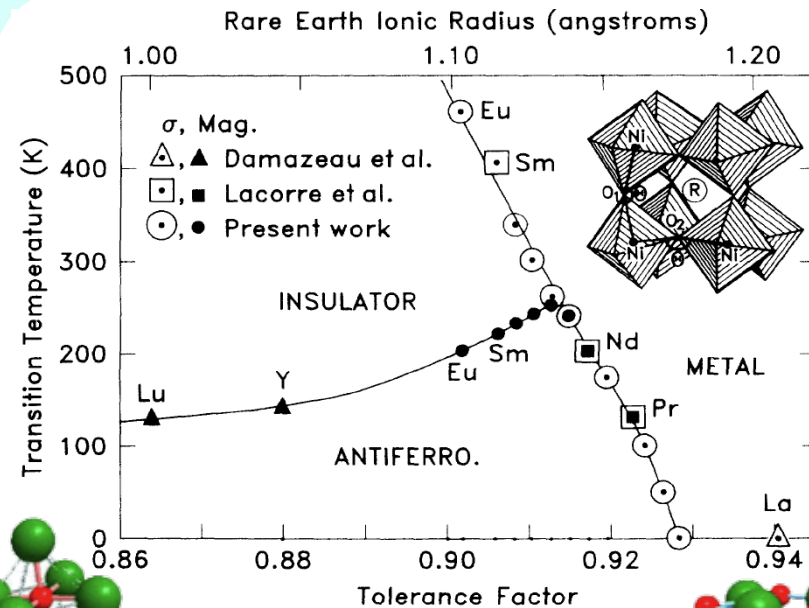
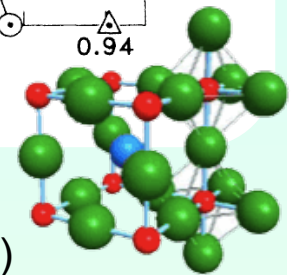
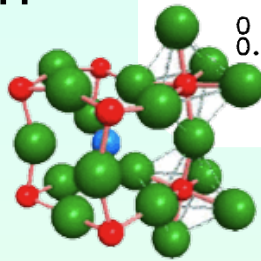
$U \ll W$ Metal

U : on-site Coulomb repulsion

W : one-electron band width



$$W \propto \cos^2 \theta$$



J.B. Torrance *et al.*,
Phys. Rev. B **45**, 8209 ('92)

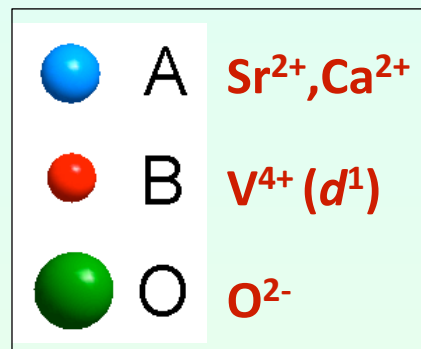
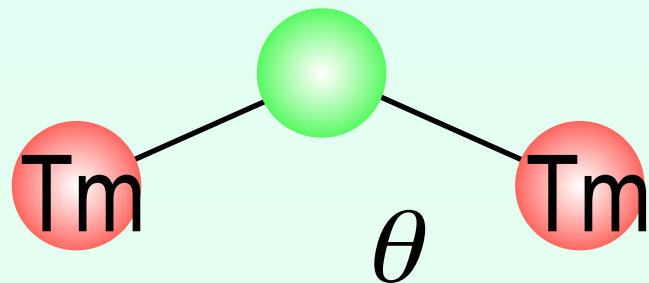
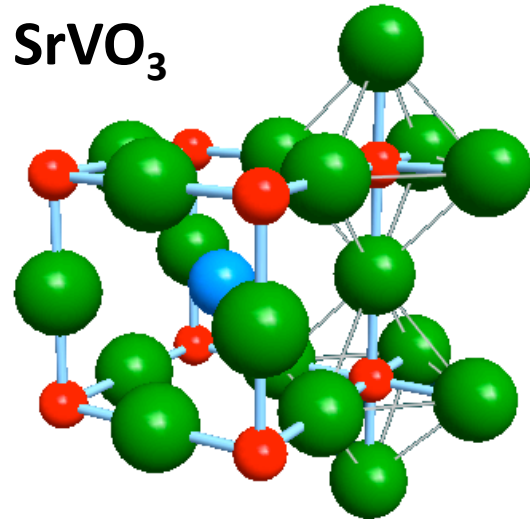
For bulk materials, MIT has been intensively studied by chemical substitution of constituent ions with ones having a smaller ion radius. However, such chemical substitution always induce randomness in a solid.

Bandwidth control in $\text{Sr}_{1-x}\text{Ca}_x\text{VO}_3$

$$W = 12t$$

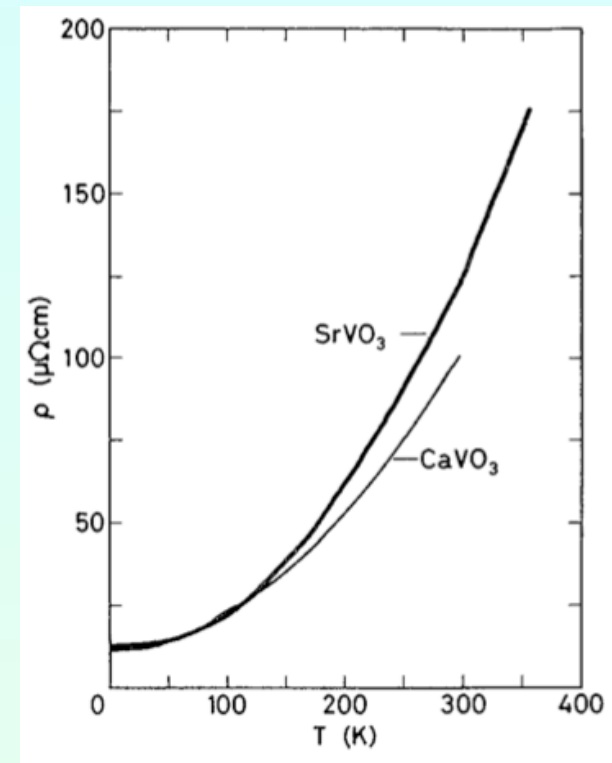
$$W = 10.6t$$

$$W \propto \cos^2\theta$$



$$\theta : \begin{array}{l} \text{SrVO}_3 \quad 180^\circ \\ \text{CaVO}_3 \quad \sim 160^\circ \end{array}$$

$\text{Sr}_{1-x}\text{Ca}_x\text{VO}_3$ is always metal in the entire x range.

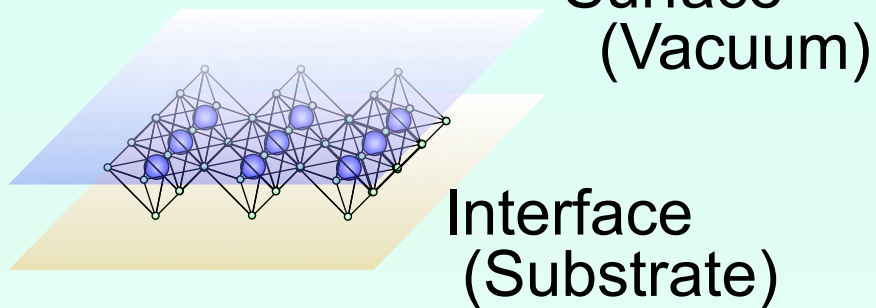


M. Onoda *et al.*, Solid State Commun. **79**, 281 (1991).

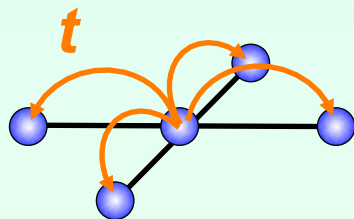
Our Approach: Dimensional crossover occurring in an $A_{n+1}B_nO_{3n+1}$

2D Digitally-controlled
 $SrVO_3$: Paramagnetic metal
 $3d^1$ system

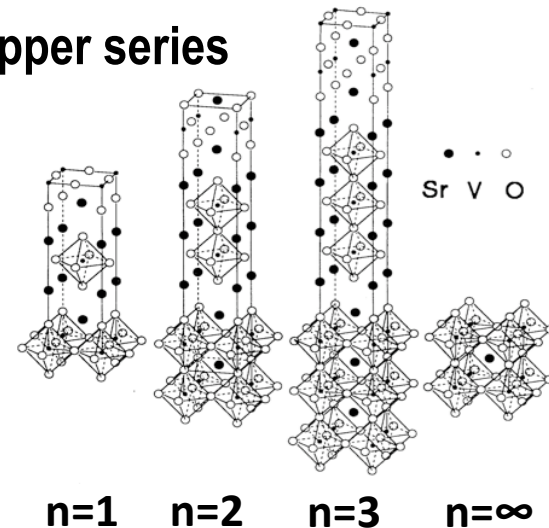
1 ML



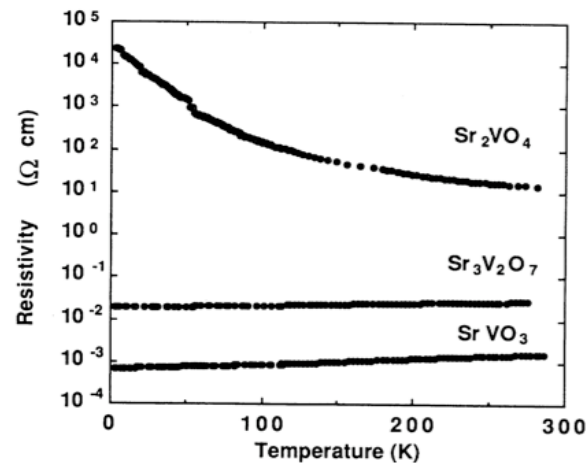
$W = 8t$



$A_{n+1}B_nO_{3n+1}$
 Ruddlesden-Popper series



n = 1
Insulator



n > 2
Metal

A. Nozaki *et al.*, Phys. Rev. B **43**, 181 (1991).

Dimensional crossover from 3D to 2D

Insulator



Metal

Our Approach: Dimensional crossover occurring in an artificial structure

Digitally-controlled SrVO₃ ultrathin films

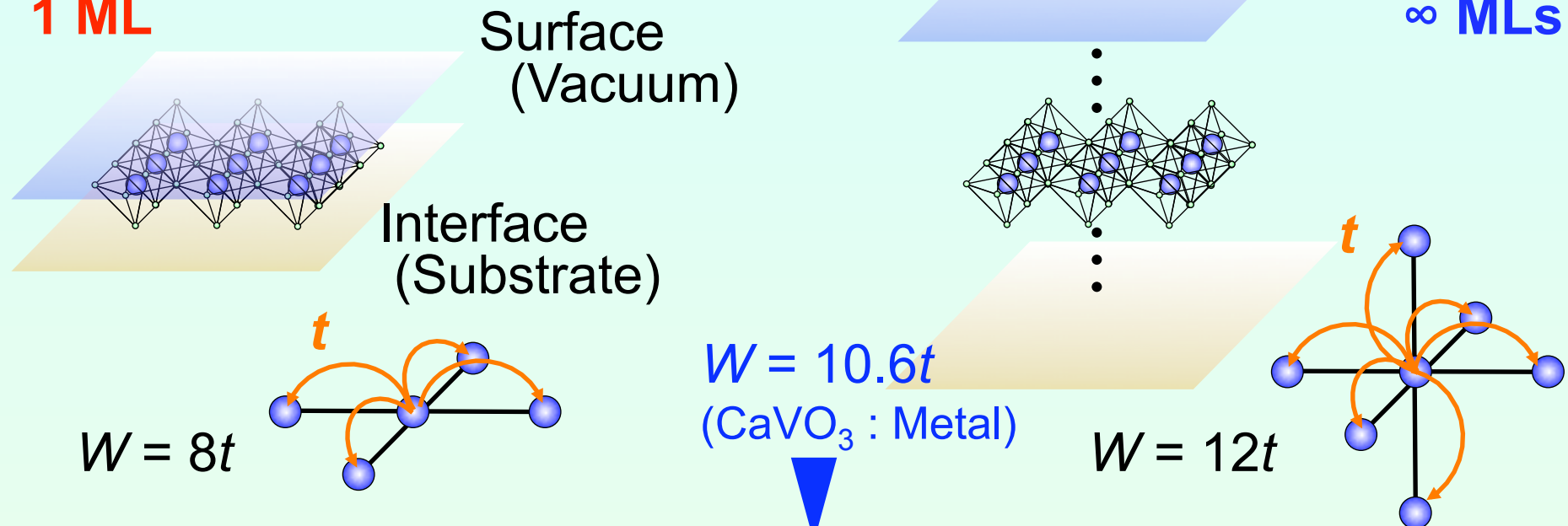
2D

SrVO₃: Paramagnetic metal
3d¹ system

3D

1 ML

∞ MLs



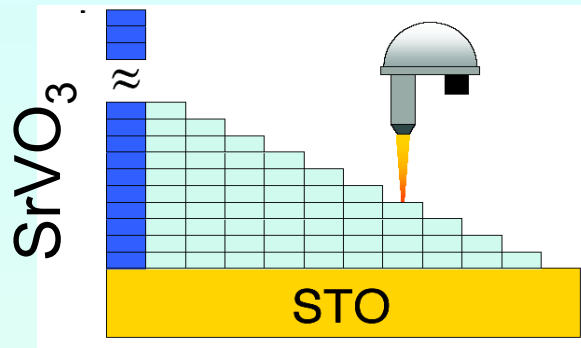
Dimensional crossover from 3D to 2D

Insulator

Metal

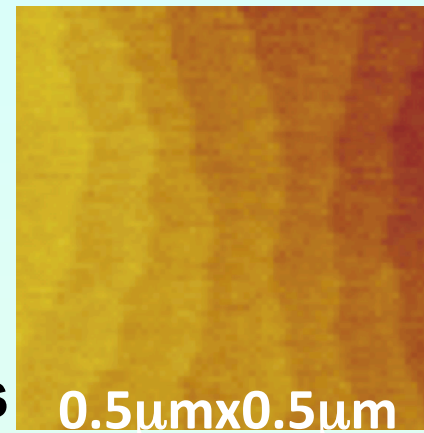
Atomically-flat Surface and Abrupt Interface

Preconditions to thickness dependent experiments

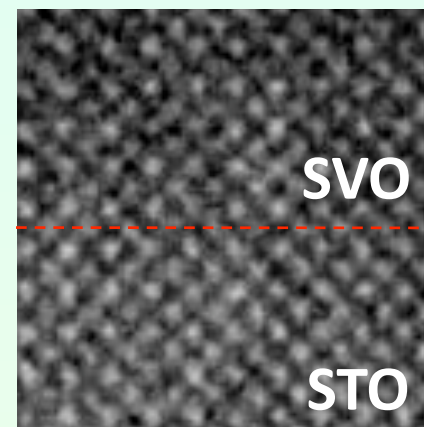


- ✓ Precise digital control of thickness (RHEED oscillation)
- ✓ Atomically flat surface (AFM image)
- ✓ Chemically abrupt interface (TEM image)
- ✓ Coherent growth of thin film (Reciprocal space mapping)

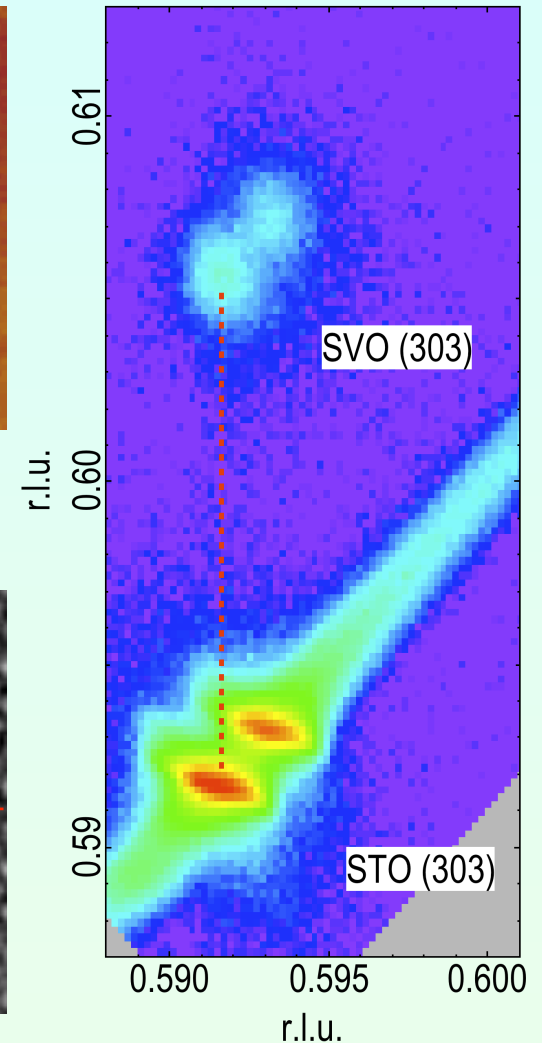
AFM image



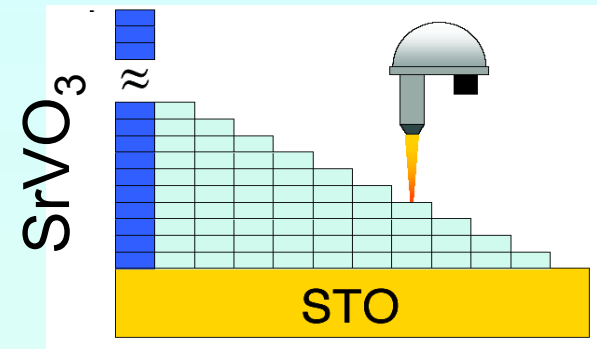
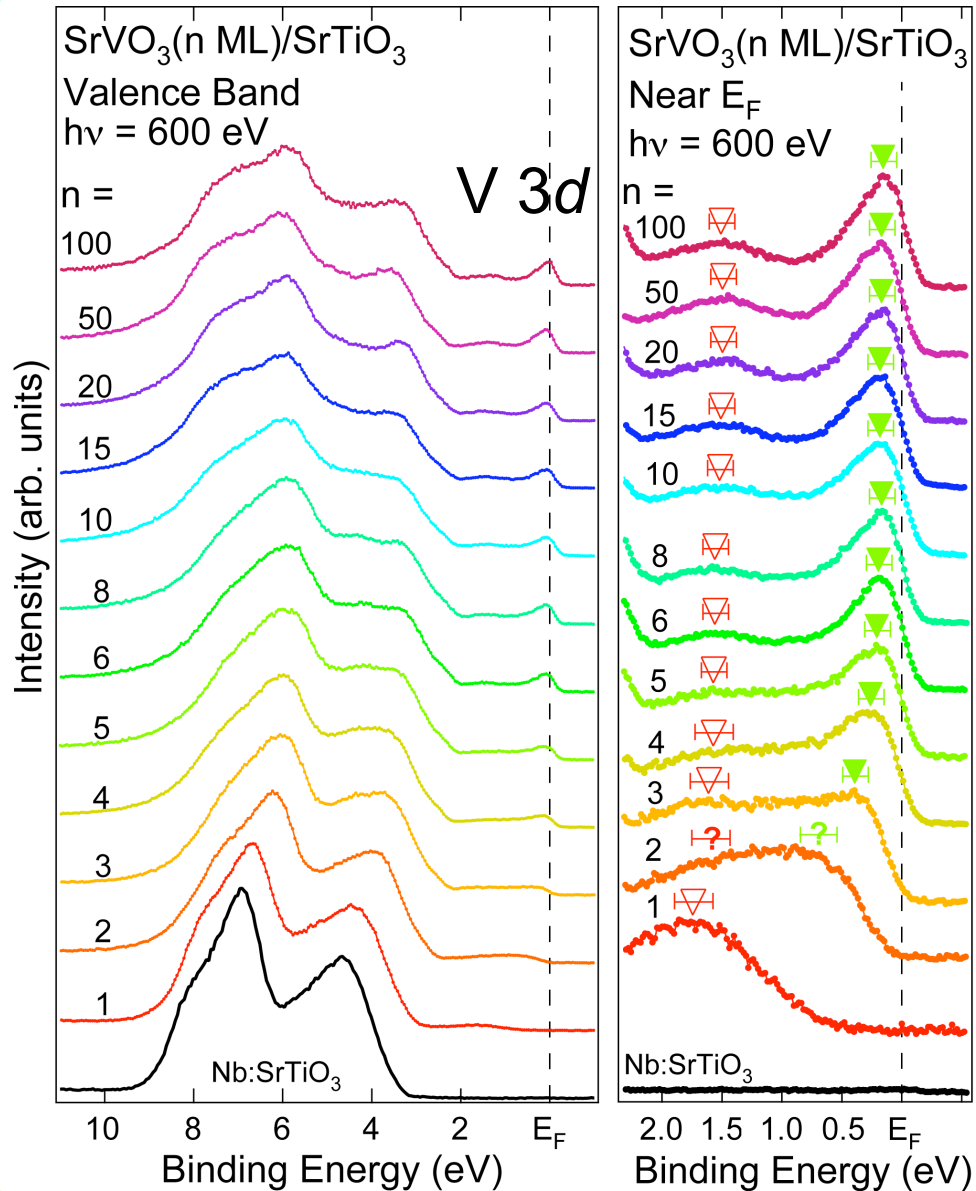
TEM image



4cXRD RSM around (303)



In situ PES Spectra of SrVO₃ thin Films



Spectra remain unchanged down to 6–8 ML

Pseudogap formation at E_F

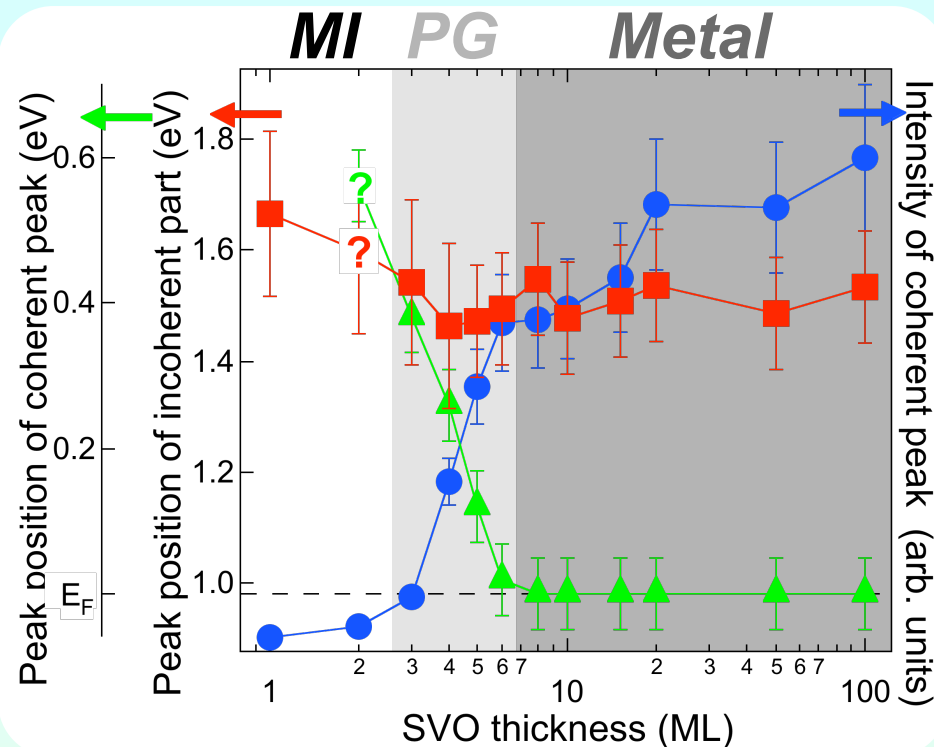
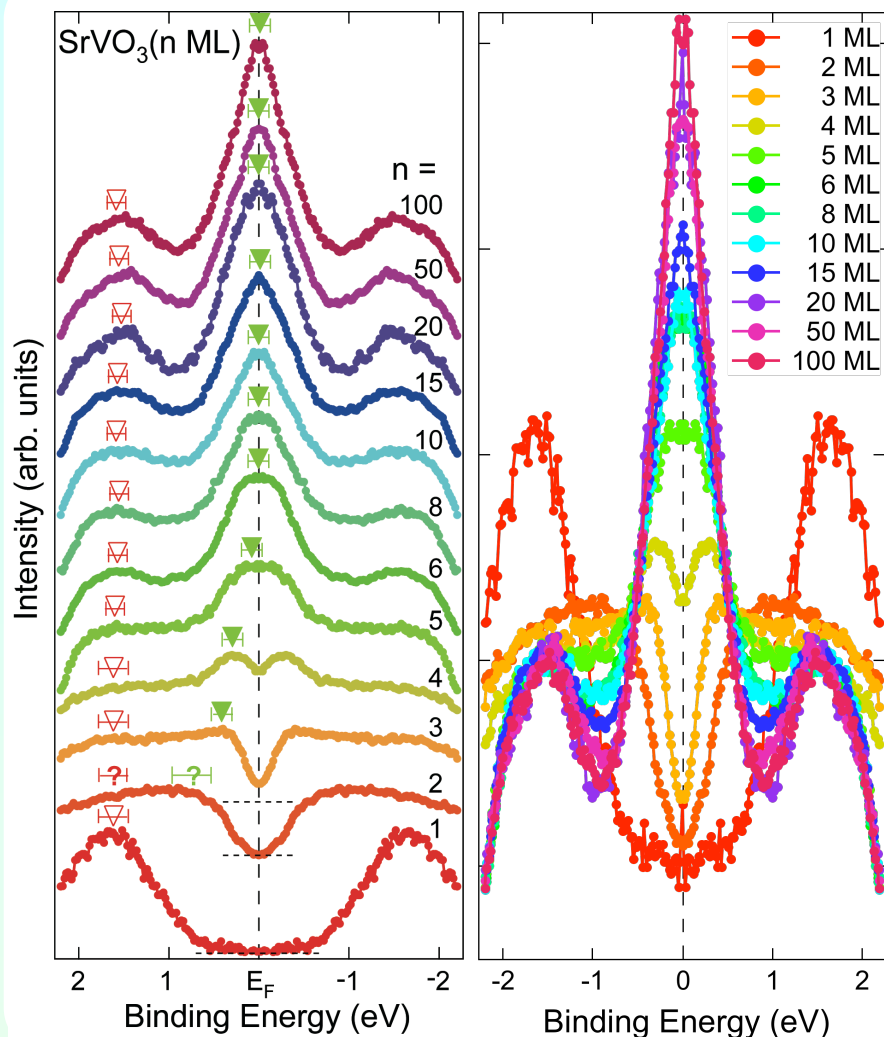
Disappearance of Fermi edge

MIT@2-3 ML

Gap at E_F

Metal-insulator transition occurs in the SVO thickness of 2-3 ML.

Dimensional-Crossover-Driven MIT in SrVO₃ Films

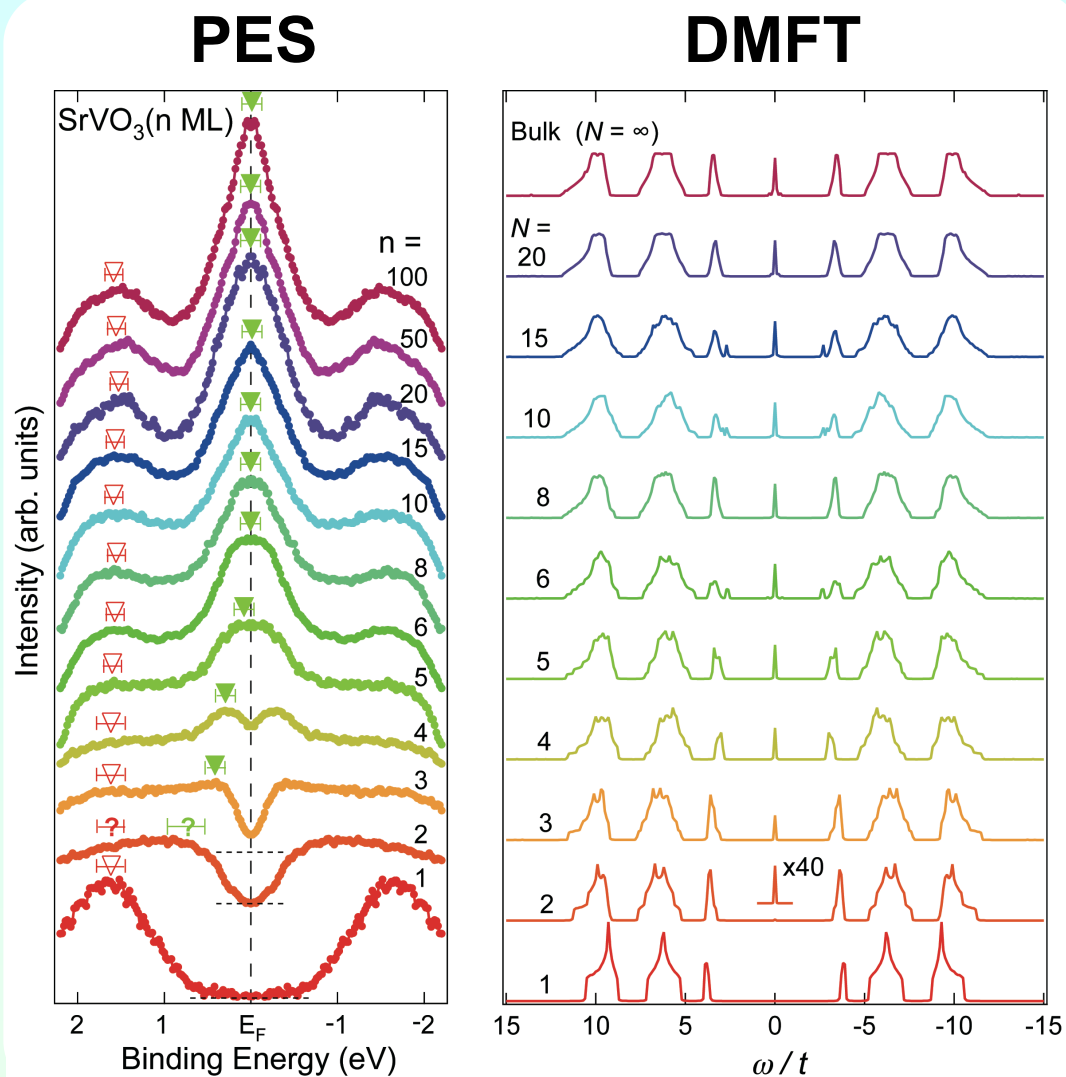


Quasiparticle peak intensity steeply increasing with increasing film thickness (W increasing).

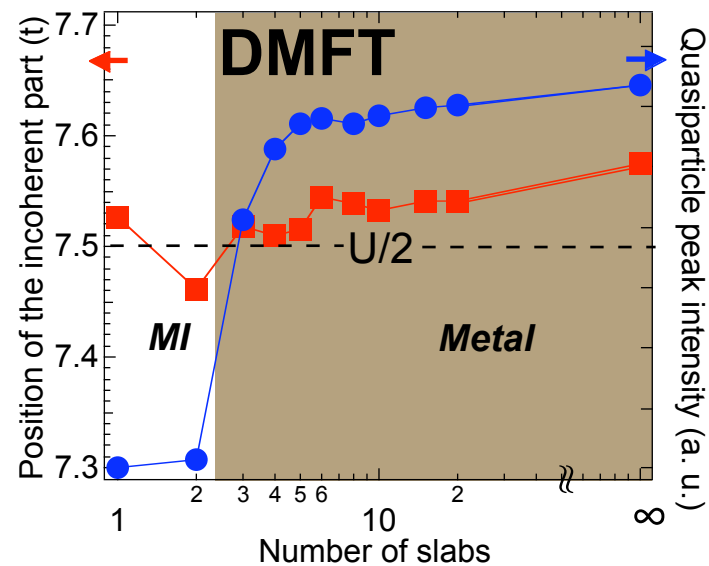
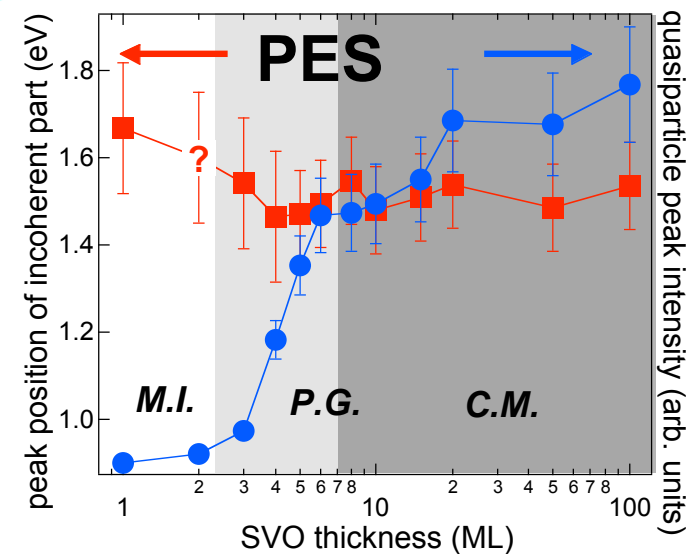
Peak position of the incoherent peak remains unchanged (U is constant).

Dimensional-Crossover-Driven (from 3D to 2D) MIT in SrVO₃ Ultrathin Films

Comparison between PES and Layer DMFT Cal.



K. Yoshimatsu, H.K., *et al.*, Phys. Rev. Lett. **104**, 147601 ('10).



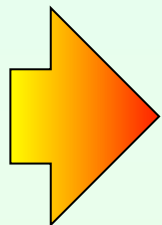
Spectral behavior is well reproduced by layer DMFT calculation.

Summary: SrVO₃ ultrathin films

We have investigated the change occurring in the electronic structure of digitally controlled SrVO₃ ultrathin films across the dimensional-crossover-driven MIT using *in-situ* photoemission spectroscopy.

We have found

1. The V 3d derived states near E_F remain unchanged down to 6–8 ML.
2. In the film thickness of 3–6 ML, a pseudogap is formed at E_F owing to the spectral weight transfer from the coherent part to incoherent part.
3. The pseudogap finally evolves into an energy gap below 2 ML, indicating the occurrence of MIT at a critical thickness of 2–3 ML.
4. These spectral behaviors are well reproduced by layer DMFT calculations.

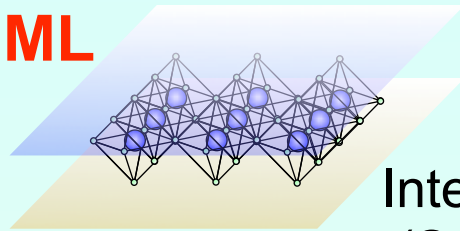


The observed MIT is caused by the reduction of bandwidth due to dimensional-crossover from 3D to 2D.

Summary

2D

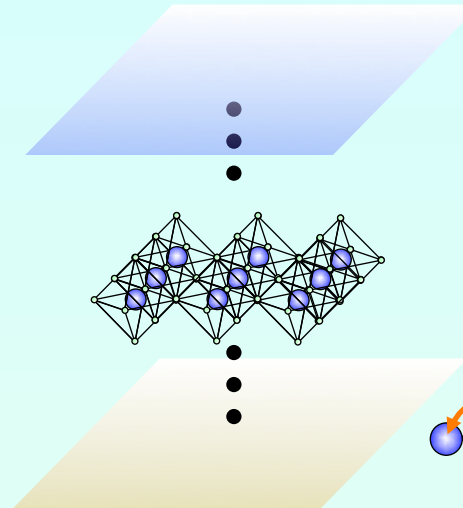
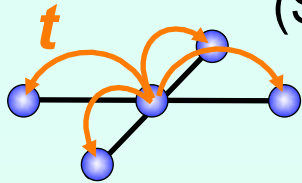
1 ML



Surface
(Vacuum)

Interface
(Substrate)

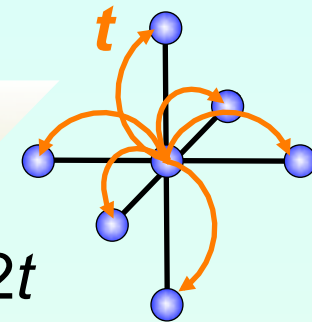
$$W = 8t$$



3D

∞ MLs

$$W = 12t$$

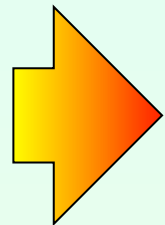


Dimensional crossover from 3D to 2D

Insulator



Metal

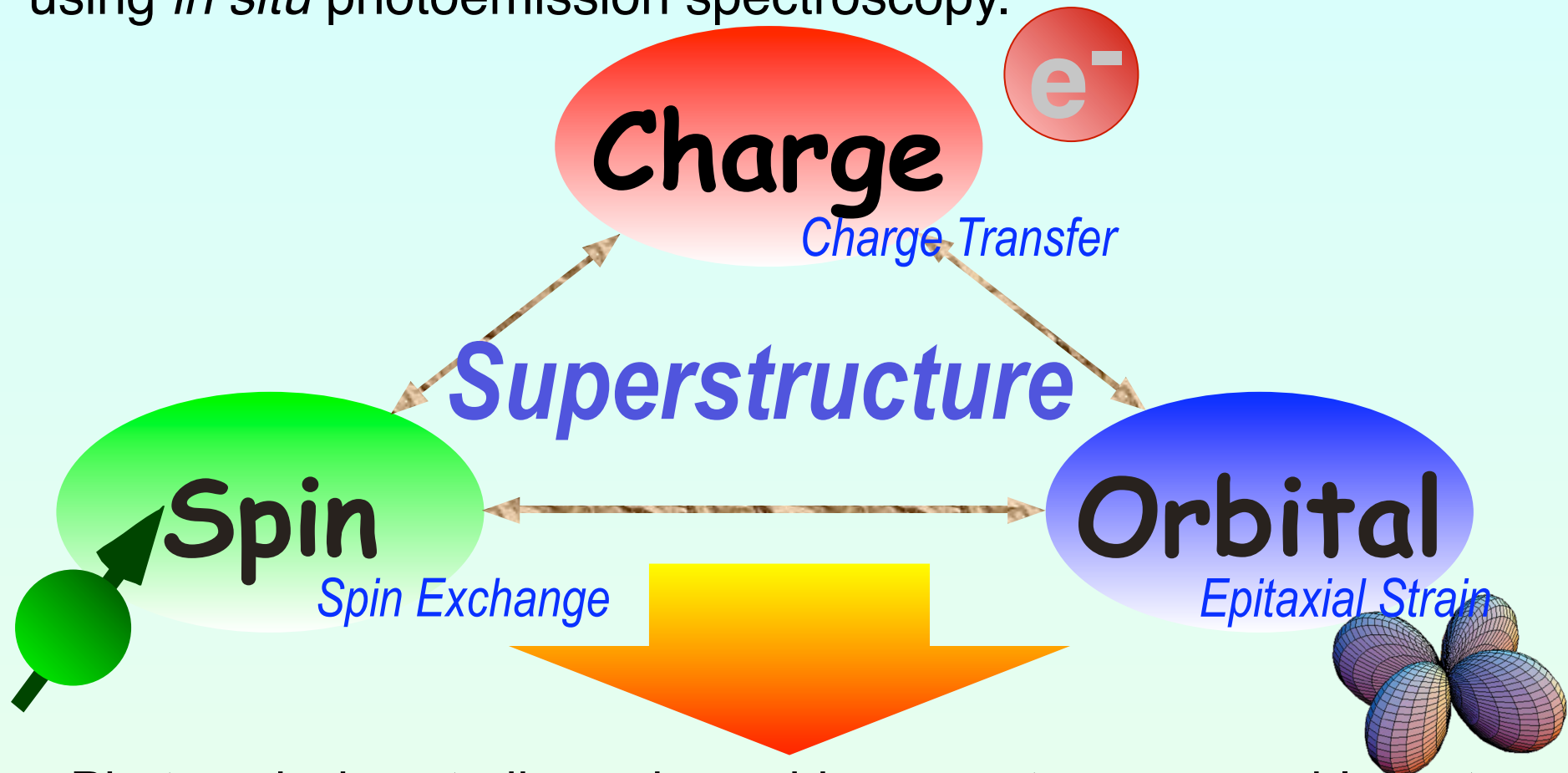


The observed MIT is caused by the reduction of bandwidth due to dimensional-crossover from 3D to 2D.

Ubiquity of thickness-dependent MIT in conductive oxide films are derived from the dimensional-crossover.

Concluding Remarks

We studied the electronic states of oxide superstructures by using *in situ* photoemission spectroscopy.



Photoemission studies using oxide superstructures enable us to pave a new way for the better understanding of the physics of strongly correlated oxides.